

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re PATENT APPLICATION of:

Ji-soo Kim et al.

Group Art Unit: Not Assigned

Serial No.: (TBD)

Examiner: Not Assigned

Filed: 30 September 2003

For: METHOD OF DETERMINING DEGREE OF CHARGE-UP INDUCED BY
PLASMA USED FOR MANUFACTURING SEMICONDUCTOR DEVICE
AND APPARATUS THEREFOR

PRELIMINARY AMENDMENT

U.S. Patent and Trademark Office
2011 South Clark Place
Customer Window, Mail Stop Patent Application
Crystal Plaza Two, Lobby, Room 1B03
Arlington, VA 22202

Sir:

Preliminary to the examination of the above-identified application, please enter the following amendments and remarks.

Amendments to the Specification begin on page 2 of this paper.

Amendments to the Claims begin on page 3 of this paper.

Remarks begin on page 6 of this paper.